



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Teiichirou Chiba *et al.*

Serial No.: 09/492,761

Filed: January 27, 2000

For: SEMICONDUCTOR WAFER

#18/D
4/2/03
John H
Examiner: C. Chu

Group Art Unit: 2815

RESPONSE UNDER 37 C.F.R. § 1.111

Honorable Commissioner
of Patents and Trademarks
Washington, D.C. 20231

March 31, 2003

Dear Sir:

The following amendments and remarks are submitted in response to the Official action mailed January 2, 2003. The Official action set forth a three-month period for response, making this response due on or before April 2, 2003.

Please amend the above-identified application as set forth on the following pages. The following amendments are being made in accordance with the "Amendments in a Revised Format Now Permitted," published in the Official Gazette on February 25, 2003, volume 1267, number 4.

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